

Message Text

UNCLASSIFIED

PAGE 01 MOSCOW 03983 250957Z POSS DUPE
ACTION NSF-02

INFO OCT-01 EUR-12 ISO-00 OES-06 CIAE-00 INR-07
NSAE-00 /028 W

-----251310Z 098564 /44

R 250910Z MAR 77
FM AMEMBASSY MOSCOW
TO SECSTATE WASHDC 5504
INFO DEPT OF COMMERCE

UNCLAS MOSCOW 3983

DEPT PASS NSF

EO 11652: NA
TAGS: TGEN PFOR UR US
SUBJECT: THIRD INTERNATIONAL SYMPOSIUM ON SILICON MATERIALS -
PHILADELPHIA, MAY 1977: SOVIET REQUEST FOR ASSISTANCE

1. GLEBOV, SCST, HAS ASKED EMBASSY AND DEPARTMENT ASSISTANCE IN
OBTAINING INFORMATION ON ABOVE CONFERENCE. ACCORDING TO GLEBOV,
THE MINISTRY OF THE ELECTRONICS INDUSTRY (MEI) WOULD LIKE TO SEND
TWO PARTICIPANTS TO THE SYMPOSIUM, WHICH GLEBOV SAID WILL BE
DEVOTED TO SILICON USE IN SEMICONDUCTORS (NOT METALLURGICAL USES,
GLEBOV'S USUAL FIELD).

2. MEI, UNABLE TO CONTACT ORGANIZATIONAL COMMITTEE OR EVEN ASCERTAIN
EXACT DATES OF SYMPOSIUM, TURNED FOR ASSISTANCE TO GLEBOV, WHO HAS
ASKED US. ACCORDING TO GLEBOV, SOVIETS WOULD HAVE BEEN PREPARED TO
PRESENT PAPERS, BUT NOW BELIEVE IT IS TOO LATE FOR ANYTHING BUT
ATTENDANCE.

3. IF DEPARTMENT CAN IDENTIFY SYMPOSIUM AND ITS ORGANIZING COM-
MITTEE, PLEASE PASS FOREGOING INFORMATION TO THEM. SIMPLEST PROCEDURE
MIGHT BE TO SUGGEST THAT ORGANIZING COMMITTEE CONTACT GLEBOV DIRECTLY
BY TELEX (SCST TELEX IS 7241 GKNT SU).

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RM PLEASE ADVISE ACTION TAKEN.
MATLOCK

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NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01-Jan-1994 12:00:00 am
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: INFORMATION EXCHANGE, FOREIGN ASSISTANCE, SCIENTIFIC MEETINGS, SILICON
Control Number: n/a
Copy: SINGLE
Sent Date: 25-Mar-1977 12:00:00 am
Decaption Date: 01-Jan-1960 12:00:00 am
Decaption Note:
Disposition Action: n/a
Disposition Approved on Date:
Disposition Case Number: n/a
Disposition Comment:
Disposition Date: 01-Jan-1960 12:00:00 am
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1977MOSCOW03983
Document Source: CORE
Document Unique ID: 00
Drafter: n/a
Enclosure: n/a
Executive Order: N/A
Errors: N/A
Expiration:
Film Number: D770102-1296
Format: TEL
From: MOSCOW
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1977/newtext/t19770322/aaaaasqv.tel
Line Count: 57
Litigation Code IDs:
Litigation Codes:
Litigation History:
Locator: TEXT ON-LINE, ON MICROFILM
Message ID: 403ad0b1-c288-dd11-92da-001cc4696bcc
Office: ACTION NSF
Original Classification: UNCLASSIFIED
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 2
Previous Channel Indicators: n/a
Previous Classification: n/a
Previous Handling Restrictions: n/a
Reference: n/a
Retention: 0
Review Action: RELEASED, APPROVED
Review Content Flags:
Review Date: 01-Oct-2004 12:00:00 am
Review Event:
Review Exemptions: n/a
Review Media Identifier:
Review Release Date: n/a
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
SAS ID: 2997486
Secure: OPEN
Status: NATIVE
Subject: THIRD INTERNATIONAL SYMPOSIUM ON SILICON MATERIALS - PHILADELPHIA, MAY 1977: SOVIET REQUEST FOR ASSISTANCE
TAGS: TGEN, PFOR, UR, US
To: STATE
Type: TE
vdkgvwkey: odbc://SAS/SAS.dbo.SAS_Docs/403ad0b1-c288-dd11-92da-001cc4696bcc
Review Markings:
Margaret P. Grafeld
Declassified/Released
US Department of State
EO Systematic Review
22 May 2009
Markings: Margaret P. Grafeld Declassified/Released US Department of State EO Systematic Review 22 May 2009